

<b>Notice of References Cited</b>	Application/Control No. 10/620,840	Applicant(s)/Patent Under Reexamination DUFF ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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**FOREIGN PATENT DOCUMENTS**

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	N	US20030115621	06-2003	PGPUB	Duff, Karen	
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**NON-PATENT DOCUMENTS**

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